FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (Modified) PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 5542.02	APPLN. NO. 09/957,401
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	APPLICANT: Herbert J. Neuhaus et al.	
(Use several sheets if necessary)	FILING DATE	GROUP
	19 September 2001	2826

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	DATE .	PATENTEE	CLASS	SUBCLASS	APPROPRIATE
Acr	4,233,103	11/1980	Shaheen	156	331	
	4,398,975	08/1983	Ohsawa et al.	148	400	
	4,485,153	11/1984	Janikowski et al.	428	688	
	5,001,829	03/1991	Schelhom	29	840	
	5,180,523	01/1993	Durand et al.	252	512	
	5,288,430	02/1994	Amemiya	252	512	
	5,493,075	02/1996	Chong et al.	174	261	
	5,551,627	09/1996	Leicht et al.	228	180.22	
	5,741,430	04/1998	Dahringer et al.	216	34	
AW	5,874,043	02/1999	Sarkhel et al.	420	557	

## FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT	PUBLISHED				TRANSLATION	
		NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
			1					<del> </del>
	-		<del> </del>		<del> </del>			
							ļ	<u> </u>
ı	- 1		1 1				J	1

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

RIX	Whalley et al., "Anisotropic Conducting Adhesives for Electronic Assembly", Microelectronics International 16/2, 1999, pp. 44-48.
	Komukai et al., "An Approach to the Anisotropic Conductive Adhesives for Micro-Interconnection Technology", Technical Paper Technology Information, October 1996.
a	John Wiley & Sons, Kirk-Othmer Encyclopedia of Chemical Technology, Third Edition, Volume 1, "Abrasives", pp 26-52, 1978.
XAMINER	DATE CONSIDERED 12/17/87

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.